

Form PTO-1449	Docket Number (Optional) 3965.4US (94-0194.04/US)	Application Number Net yet assigned 10/704,244
INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>	Applicant Ravi Iyer	
	Filing Date November 12, 2003	Group Art Unit <i>2825</i> Unknown

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
CYME	4,925,813	05/1990	Autier et al.			
CYME	5,052,339	10/1991	Vakerlis et al.			
CYME	5,094,711	03/1992	Narasimhan et al.			
CYME	5,260,107	11/1993	Kawamura et al.			
CYME	5,344,792	09/1994	Sandhu et al.			
CYME	5,645,900	07/1997	Ong et al.			
CYME	5,665,431	09/1997	Narasimhan			
CYME	5,846,881	12/1998	Sandhu et al.			
CYME	5,946,594	08/1999	Iyer et al.			
CYME	6,184,136	02/2001	Iyer et al.			
CYME	6,340,637	01/2002	Iyer et al.			
CYME	6,653,234	11/2003	Iyer et al.			

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

CYME		D. Kim et al., "Properties of TiN-TiC Multilayer Coatings Using Plasma-Assisted Chemical Vapor Deposition," Surface and Coatings Technology, Vol. 116-119, pp. 906-10 (9/1999),

EXAMINER <i>C. Luerkens</i>	DATE CONSIDERED <i>7/16/04</i>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance. Include copy of this form with next communication to the applicant.